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SIEMENS

PATENT
Attorney Docket No. 2001P17947WOUS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE.

In re Application of:

Inventor: A. Jeutter et al.

Group Art Unit: 1753

Serial No.: 10/659,219

Examiner: E. Wong

Filed: September 10, 2003

Title: **METHOD FOR COATING A SUBSTRATE HAVING HOLES**

Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

RESPONSE TO FINAL OFFICE ACTION

In response to the final Office Action mailed December 5, 2006, Applicants respectfully submit the following amendments and remarks in connection with the above-identified application to place the claims in condition for allowance or to place the claims in better form for appeal should the Examiner dispute the patentability of the amended claims.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper

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